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Ken Yamada was born in Sendai, Japan on September 10, 1951. He received the B.S. and Ph.D degrees in electrical communication engineering from Tohoku University, Sendai, Japan in 1974 and 1979, respectively. Since 1980, he has been a Research Associate at the Department of Electrical Communications, Faculty of Engineering, Tohoku University. He has been engaged in research works on piezoelectric resonators and filters, ultrasonic transducers, and acoustic microscopy. He is a member of the Institute of the Electronics, Information and Communication Engineers of Japan, and the Institute of Electrical and Electronics Engineers. He received the Awaya Kiyoshi Award from the Acoustical Society of Japan in 1984.



Hiroshi Shimizu was born in Niigata City, Japan, on April 17, 1925. He received the B.S. and Ph.D degrees in electrical engineering from Tohoku University, Sendai, Japan in 1948 and 1962, respectively. He was a Research Associate from 1948 to 1955 and an Associate Professor from

1955 to 1962 at the Research Institute of Electrical Communication, Tohoku University. From 1962 to 1989, he was a Professor at the Department of Electrical Communications, Faculty of Engineering of the same university. From 1989 to 1991, he was a Professor at the University of Electro-Communications, Chofu-shi, Japan. He has been engaged in research works in the field of electroacoustics, applied ultrasonics, and electromechanical functional devices. He is a member of the Institute of Electrical Engineers of Japan, the Institute of the Electronics, Information and Communication Engineers of Japan, the Japan Society of Applied Physics, the Japan Society of Ultrasonics in Medicine, and the Institute of Electrical and Electronics Engineers. He was a vicepresident of the Acoustical Society of Japan from 1987 to 1989.